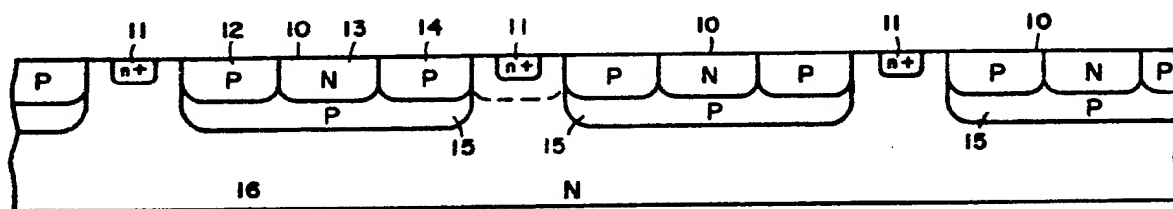


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## INTERNATIONAL APPLICATION PUBLISHED UNDER THE PATENT COOPERATION TREATY (PCT)

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<b>(21) International Application Number:</b> PCT/US85/00262 <b>(22) International Filing Date:</b> 14 February 1985 (14.02.85) <b>(31) Priority Application Number:</b> 582,003 <b>(32) Priority Date:</b> 21 February 1984 (21.02.84) <b>(33) Priority Country:</b> US  <b>(71) Applicant:</b> AMERICAN TELEPHONE & TELEGRAPH COMPANY [US/US]; 550 Madison Avenue, New York, NY 10022 (US). <b>(72) Inventors:</b> MEYER, William, George ; 2315 LaSalle Drive, Whitfield, PA 19609 (US). OLSON, Karel, Hugh ; 3423 Eisenhower Avenue, Reading, PA 19605 (US). <b>(74) Agents:</b> HIRSCH, A., E., Jr. et al.; Post Office Box 901, Princeton, NJ 08540 (US).		<b>(81) Designated States:</b> AT (European patent), BE (European patent), CH (European patent), DE (European patent), FR (European patent), GB (European patent), JP, LU (European patent), NL (European patent), SE (European patent).  <b>Published</b> <i>With international search report.</i>

**(54) Title:** VERSATILE GENERIC CHIP SUBSTRATE**(57) Abstract**

A variety of semiconductor devices and technologies can be integrated conveniently using a generic modular substrate (16). The substrate contains modules (10) that can be isolated from each other and from the substrate. This design approach is especially useful for combining high and low voltage functions in the same chip and for integrating analog and digital devices. It is well adapted for CMOS implementations.

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## VERSATILE GENERIC CHIP SUBSTRATE

Background of the Invention

There are growing applications for circuits that  
5 integrate families of devices, e.g. MOS-bipolar, or diverse  
functions, e.g. digital-analog, high voltage-low voltage,  
in the same chip.

Statement of the Invention

We have invented a versatile generic chip  
10 substrate that can accommodate a wide variety of device  
families in a convenient integrated standard array. The  
substrate contains an intra-isolated array of device sites  
each of which may contain one or more devices of the  
variety of device families.

15 In a preferred embodiment the generic chip  
substrate is used to form pairs of high voltage and low  
voltage CMOS devices.

Brief Description of the Drawings

FIGS. 1A-1C are schematic representations of the  
20 generic chip substrate (GCS) which comprises the broad  
aspect of the invention;

FIGS. 2A-2K ("I" omitted) are schematic  
representations of an exemplary group of devices that can  
be formed in a selected site of the GCS;

25 FIG. 3 is a schematic view of a preferred  
embodiment of the invention showing low voltage and high  
voltage complementary transistors in a GCS implementation;

FIG. 4 is a schematic representation of a CMOS  
device integrating digital and analog functions.

Detailed Description

30 The standard generic chip substrate (GCS) is shown  
in FIG. 1A and comprises a semiconductor n-substrate 16  
with an array of device sites 10 formed as shown. Regions  
11 isolate the sites from one another. Each site comprises  
35 a sequence of p-n-p tubs 12, 13, 14 formed within a p-well  
15. Dimensions of the tubs and doping levels of the  
various regions are a function of the actual semiconductor

- 2 -

devices to be integrated. A slight variation of the monolithic array illustrated in FIG. 1A would have varying dimensions and doping from site to site with selected sites optimized for a given device family. However the basic ingredients would be common to each site, i.e. n and p tubs in a p-well. (Complementary structures can be used as well.) The sites may be completely isolated from the nearest neighbor as shown schematically in FIG. 1B (plan view) or they can be isolated in groups or rows as indicated in FIG. 1C.

Exemplary of the wide variety of device families that can be accommodated by the GCS are those shown in FIGS. 2A-2K (Legend "21" has been omitted). Other possibilities are possible. The devices in each site have the capability of being totally isolated from other devices in the array. This feature is especially useful when integrating analog and digital devices or high voltage and low voltage devices on the same chip. This layout scheme is shown in plan view in FIG. 1B. Applications will be found in which a series of, for example, low voltage CMOS pairs are advantageously laid out in a row or rows where it is unnecessary to isolate each channel from the others but it is still desirable to isolate the row from other devices, i.e. to isolate the row from the remainder of the chip substrate. In that case the isolating p-well can be formed as a continuous elongated well as shown in FIG. 1C. The basic structure of FIG. 1A is common to either layout.

Referring to FIG. 1A there is shown in dashed lines an n-tub in the separation between the p-wells. While the n-tub in itself provides a degree of isolation, it is often desirable to add the more heavily doped ( $n^+$ ) region 11 to insure against surface inversion and inter-device leakage. Alternatively, the  $n^+$  region can be used alone and the inter modular spacing optimized for the type and degree of isolation desired.

A high voltage-low voltage CMOS device is shown in FIG. 3. The high voltage device comprises source-substrate

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connected structures which are built within p-wells, (11 and 11') across n-tub - p-tub boundaries, utilizing polysilicon as the gate electrodes (12 and 12'). The device structures are as follows:

5           1) High voltage p-channel: the n-tub region 16 under the polysilicon gate 12 and 2000A gate oxide 13 serves as the inversion region (channel), and the p-tub region 14 under the polysilicon gate 12 and field oxide 15 serves as the drift region.  
10           The source and drain are shown at 17 and 18 respectively.

          2) n-channel: the p-tub region 16' under the polysilicon gate 12' and 2000A gate oxide 13' serves as the inversion region (channel), and the  
15           n-tub region 14' under the polysilicon gate 12' and field oxide 15' serves as the drift region. The source and drain are shown at 17' and 18' respectively.

          The portion of the polysilicon gate which runs  
20           over the drift region serves as a field plate and insures that the drift region does not become inverted due to stray electric fields. The  $n^+$  and  $p^+$  guard rings 19 and 20 serve as channel stops, i.e. serve to raise the field inversion threshold. Metal contacts are shown at 20. (The  
25           gate contacts do not appear in this view.)

          3) Low voltage p-channel: the n-tub region 30 under the polysilicon gate 31 provides the channel between source 32 and drain 33.

30           4) Low voltage n-channel: the p-tub region 30' under the polysilicon gate 31' provides the channel between source 32' and drain 33'. Metal contacts (gate contacts not shown) are denoted 34.

          We have fabricated both n- and p-channel HV-CMOS  
35           devices with drain to source breakdown voltages greater than 100 volts. Device characteristics are presented in the following Table. Devices had these dimensions:

- 4 -

width = 200  $\mu\text{m}$ , length = 15  $\mu\text{m}$ , drift region 10  $\mu\text{m}$ .  
 Additional details on device structure and fabrication  
 appear in IEEE Journal of Solid-State Circuits, E. Habekotte,  
 B. Hoefflinger, W. Renker, and G. Zimmer, Vol. SC-16,  
 5 No. 3, June, 1981.  $R_{\text{ON}}$  in the Table is on-resistance  
 measured with  $V_{\text{GS}}=10\text{V}$  and  $V_{\text{DS}}=1\text{V}$ .  $C_{\text{GD}}$  in  
 the Table is the gate/drain overlap capacitance.

#### HV CMOS Device Characteristics

	$R_{\text{ON}}$ (HV-NCH)	1.08k $\Omega$
10	$R_{\text{ON}}$ (HV-PCH)	10.1k $\Omega$
	$C_{\text{GD}}$	$7.67 \times 10^{-14} \text{F}$
	$C_{\text{GD}}/\text{Width}$	$3.84 \times 10^{-16} \text{F}/\mu\text{m}$ of width

The addition of a p-well to the CMOS process  
 affords a variety of additional design capabilities. For  
 15 example:

- 1) Low voltage p-channel devices can be fabricated  
 in n-tubs contained within a p-well (FIG. 2B),  
 thus providing individually isolated p-channel  
 devices.
- 20 2) Low voltage digital circuits can be fabricated  
 in one large p-well (FIG. 4), thus providing a  
 vehicle for isolating analog and digital portions  
 of a circuit.
- 25 3) Complementary bipolar transistors (nnp and pnp)  
 can be fabricated within the p-well (FIG. 2H).  
 These devices are also individually isolated from  
 each other and the substrate.
- 30 4) If one utilizes the substrate, a controlled  
 pnpn SCR is also available (FIG. 2H).

- 5 -

Claim

An integrated semiconductor structure comprising a semiconductor substrate (16) of a first conductivity type having a plurality of repeating cell units,

## CHARACTERIZED IN THAT

each unit comprises a relatively deep well (15) having a second conductivity type opposite to that of the substrate, each said well contains at least three contiguous tubs (12, 13, 14) of alternating conductivity type, isolating means (11) between at least selected wells for electrically isolating those wells from each other, and at least one p-n junction device (e.g., FIG. 3) formed in at least one of said tubs.

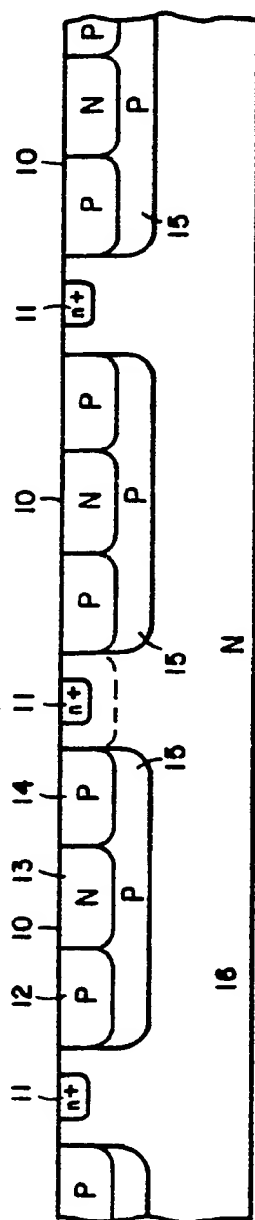
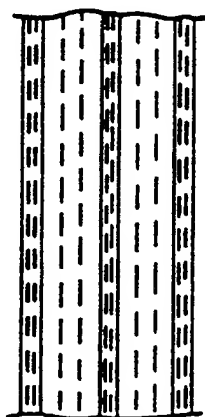
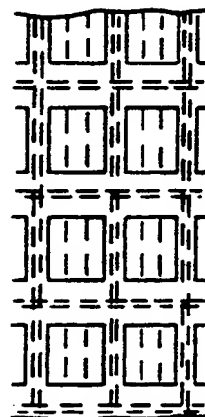


FIG. 1A



**FIG. 1C**



**FIG. 1B**



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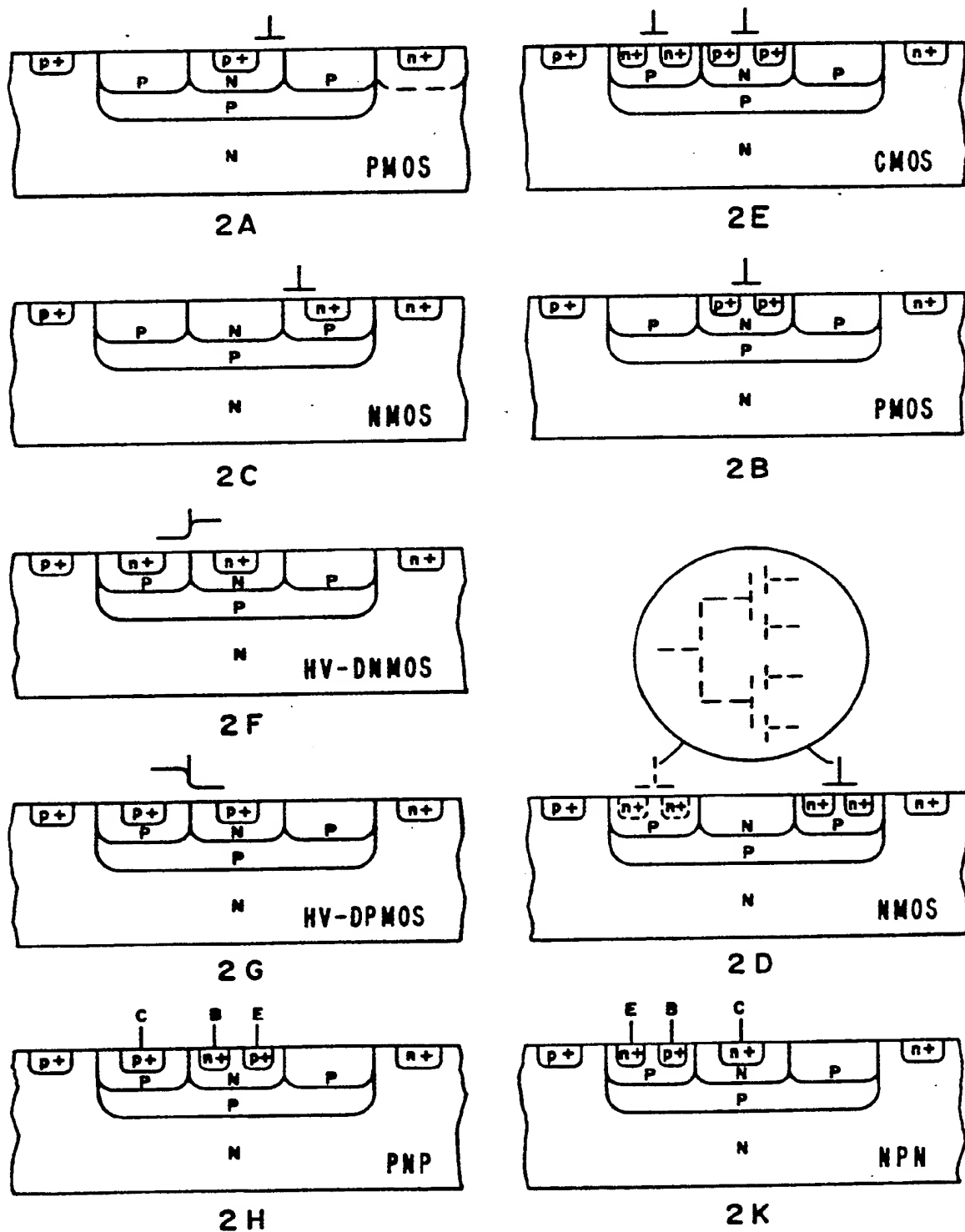


FIG. 2

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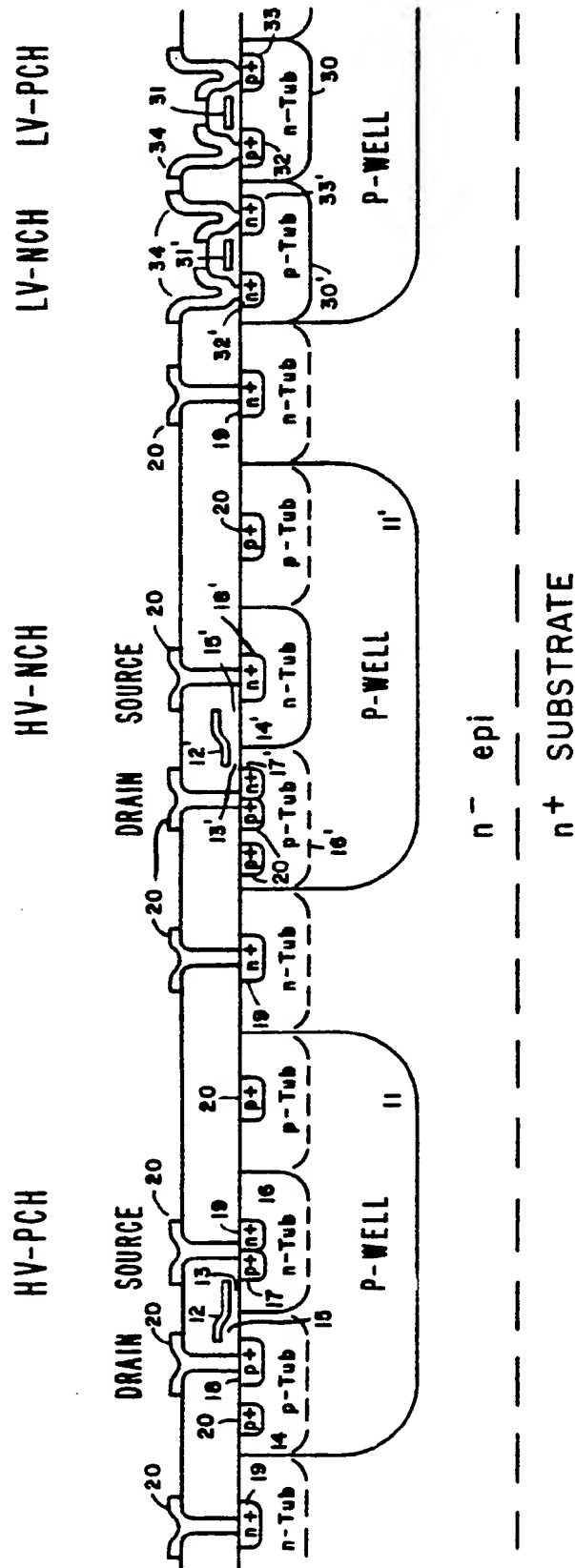


FIG. 3

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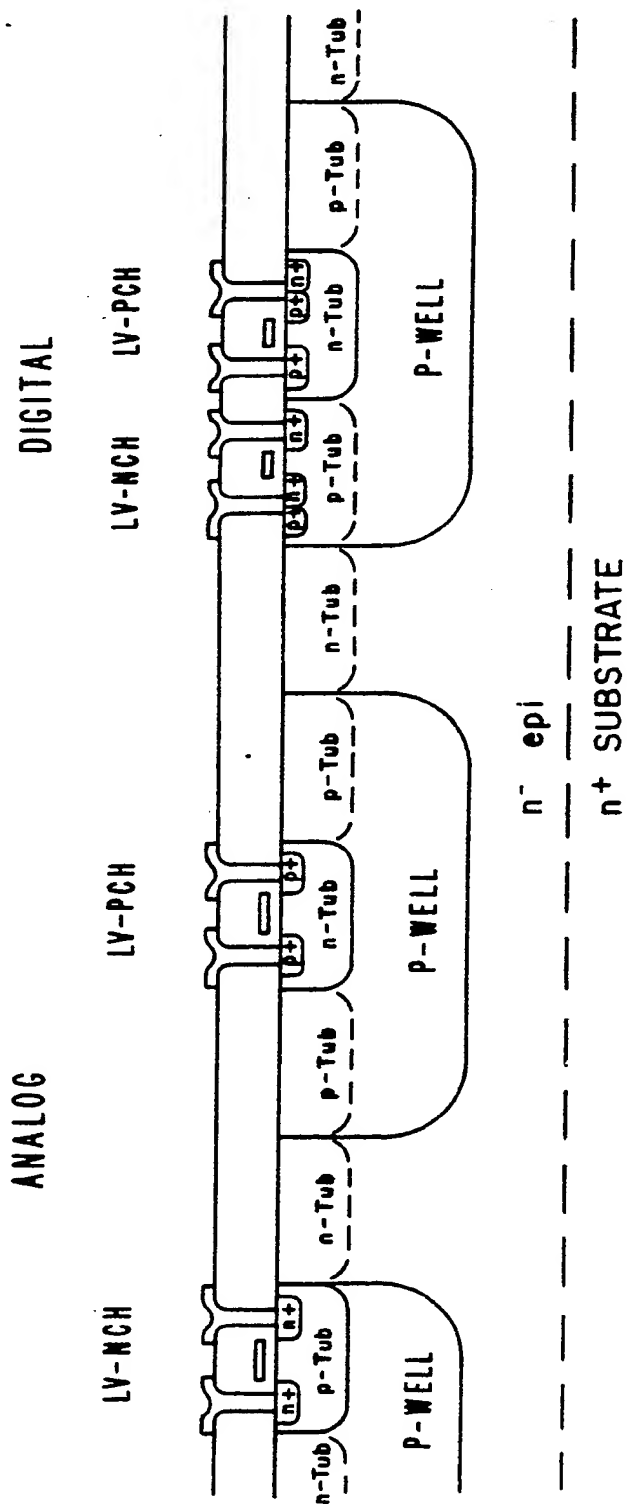


FIG. 4

# INTERNATIONAL SEARCH REPORT

International Application No PCT/US 85/00262

<b>I. CLASSIFICATION OF SUBJECT MATTER</b> (if several classification symbols apply, indicate all) <sup>4</sup> According to International Patent Classification (IPC) or to both National Classification and IPC IPC <sup>4</sup> :      H 01 L 27/06; H 01 L 21/76																	
<b>II. FIELDS SEARCHED</b> <div style="text-align: center; border-top: 1px solid black; border-bottom: 1px solid black; margin: 5px 0;">Minimum Documentation Searched <sup>7</sup></div> <table style="width: 100%; border-collapse: collapse;"> <tr> <th style="width: 25%; border-bottom: 1px solid black;">Classification System</th> <th style="border-bottom: 1px solid black;">Classification Symbols</th> </tr> <tr> <td style="border: 1px solid black; padding: 5px;">IPC<sup>4</sup></td> <td style="border: 1px solid black; padding: 5px;">H 01 L</td> </tr> </table> <div style="text-align: center; border-top: 1px solid black; border-bottom: 1px solid black; margin: 5px 0;">Documentation Searched other than Minimum Documentation to the Extent that such Documents are Included in the Fields Searched <sup>8</sup></div>			Classification System	Classification Symbols	IPC <sup>4</sup>	H 01 L											
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IPC <sup>4</sup>	H 01 L																
<b>III. DOCUMENTS CONSIDERED TO BE RELEVANT <sup>9</sup></b> <table style="width: 100%; border-collapse: collapse;"> <tr> <th style="width: 10%; border-bottom: 1px solid black;">Category <sup>9</sup></th> <th style="width: 70%; border-bottom: 1px solid black;">Citation of Document, <sup>11</sup> with Indication, where appropriate, of the relevant passages <sup>12</sup></th> <th style="width: 20%; border-bottom: 1px solid black;">Relevant to Claim No. <sup>13</sup></th> </tr> <tr> <td style="text-align: center; vertical-align: top; padding: 5px;">A</td> <td style="padding: 5px;">Patents Abstracts of Japan, vol. 8, no. 25 (E-225) (1462), 2 February 1984 &amp; JP, A, 58188152 (Nippon Denki K.K.) 2 November 1983, see abstract and figures</td> <td style="text-align: center; vertical-align: top; padding: 5px;">1</td> </tr> <tr> <td style="text-align: center; vertical-align: top; padding: 5px;">A</td> <td style="padding: 5px;">IEEE Journal of Solid-State Circuits, vol. SC-18, no. 3, June 1983 (New York, US) B.T. Murphy: "Micro-computers: trends, technologies and design strategies", pages 236-244, see page 238, figures 4-5, column 2</td> <td style="text-align: center; vertical-align: top; padding: 5px;">1</td> </tr> <tr> <td style="text-align: center; vertical-align: top; padding: 5px;">A</td> <td style="padding: 5px;">US, A, 4403395 (P.A. CURRAN) 13 September 1983 see figure 12; column 1, lines 1-37</td> <td style="text-align: center; vertical-align: top; padding: 5px;">1</td> </tr> <tr> <td style="text-align: center; vertical-align: top; padding: 5px;">A</td> <td style="padding: 5px;">IEEE Journal of Solid-State Circuits, vol. SC-16, no. 3, June 1981 (New York, US) E. Habekotté et al.: "A coplanar CMOS power switch", pages 212-226, see figure 17 (cited in the application)</td> <td style="text-align: center; vertical-align: top; padding: 5px;">1 ./.</td> </tr> </table>			Category <sup>9</sup>	Citation of Document, <sup>11</sup> with Indication, where appropriate, of the relevant passages <sup>12</sup>	Relevant to Claim No. <sup>13</sup>	A	Patents Abstracts of Japan, vol. 8, no. 25 (E-225) (1462), 2 February 1984 & JP, A, 58188152 (Nippon Denki K.K.) 2 November 1983, see abstract and figures	1	A	IEEE Journal of Solid-State Circuits, vol. SC-18, no. 3, June 1983 (New York, US) B.T. Murphy: "Micro-computers: trends, technologies and design strategies", pages 236-244, see page 238, figures 4-5, column 2	1	A	US, A, 4403395 (P.A. CURRAN) 13 September 1983 see figure 12; column 1, lines 1-37	1	A	IEEE Journal of Solid-State Circuits, vol. SC-16, no. 3, June 1981 (New York, US) E. Habekotté et al.: "A coplanar CMOS power switch", pages 212-226, see figure 17 (cited in the application)	1 ./.
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<div style="display: flex; justify-content: space-between;"> <div style="width: 45%;"> <p><sup>10</sup> Special categories of cited documents:</p> <p>"A" document defining the general state of the art which is not considered to be of particular relevance</p> <p>"E" earlier document but published on or after the international filing date</p> <p>"L" document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified)</p> <p>"O" document referring to an oral disclosure, use, exhibition or other means</p> <p>"P" document published prior to the international filing date but later than the priority date claimed</p> </div> <div style="width: 45%;"> <p>"T" later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention</p> <p>"X" document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step</p> <p>"Y" document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art.</p> <p>"&amp;" document member of the same patent family</p> </div> </div>																	
<b>IV. CERTIFICATION</b> <table style="width: 100%; border-collapse: collapse;"> <tr> <td style="width: 50%; border-bottom: 1px solid black; padding: 5px;">Date of the Actual Completion of the International Search</td> <td style="width: 50%; border-bottom: 1px solid black; padding: 5px;">Date of Mailing of this International Search Report</td> </tr> <tr> <td style="border-bottom: 1px solid black; padding: 5px; text-align: center;">13th May 1985</td> <td style="border-bottom: 1px solid black; padding: 5px; text-align: center;">13.11.1985</td> </tr> <tr> <td style="border-bottom: 1px solid black; padding: 5px;">International Searching Authority</td> <td style="border-bottom: 1px solid black; padding: 5px;">Signature of Authorized Officer</td> </tr> <tr> <td style="padding: 5px; text-align: center;">EUROPEAN PATENT OFFICE</td> <td style="padding: 5px; text-align: center;">             G.L.M. Kruidenberg         </td> </tr> </table>			Date of the Actual Completion of the International Search	Date of Mailing of this International Search Report	13th May 1985	13.11.1985	International Searching Authority	Signature of Authorized Officer	EUROPEAN PATENT OFFICE	 G.L.M. Kruidenberg							
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A	Patents Abstracts of Japan, vol. 7, no. 99 (E-172) (1244), 27 April 1983 & JP, A, 5821857 (Suwa Seikosha K.K.) 8 February 1983; see abstract and figures -----	1

ANNEX TO THE INTERNATIONAL SEARCH REPORT ON

INTERNATIONAL APPLICATION NO.

PCT/US 8500262 (SA 8981)

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Patent document cited in search report	Publication date	Patent family member(s)	Publication date
US-A- 4403395	13/09/83	FR-A,B 2449334	12/09/80
		DE-A- 3005384	28/08/80
		NL-A- 8000665	19/08/80
		JP-A- 55146944	15/11/80
		US-A- 4325180	20/04/82

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